| Electronic Ack | knowledgement Receipt |
|--------------------------------------|---|
| EFS ID: | 2189657 |
| Application Number: | 10812411 |
| International Application Number: | |
| Confirmation Number: | 1274 |
| Title of Invention: | EUV lithography system and chuck for releasing reticle in a vacuum isolated environment |
| First Named Inventor/Applicant Name: | Siegfried Schwarzl |
| Customer Number: | 25227 |
| Filer: | Ira Stuart Matsil/Shelley Butz |
| Filer Authorized By: | Ira Stuart Matsil |
| Attorney Docket Number: | 543822004700 |
| Receipt Date: | 12-SEP-2007 |
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| Time Stamp: | 18:31:27 |
| Application Type: | Utility under 35 USC 111(a) |

Payment information:

| Submitted with Payment | no |
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File Listing:

| Document Number | Document Description | File Name | File Size(Bytes) /Message Digest | Multi Part /.zip | Pages (if appl.) |
|--------------------|----------------------|---|-------------------------------------|---------------------|---------------------|
| , | | QIM04 50143 Amendment. | 288070 | ves | |
| ' | pdf | cc38faaaaa5cc9e67fa869e644b9199d12 af7caaf | | | |

| | Multipar | t Description/PDF files in | .zip description | | |
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| | Document Description | | Start En | | nd |
| | Amendment - After Non-Final Rejection | | 1 | 1 | |
| | Specification | | 2 | 2 | |
| | Claims | | 3 | 6 | |
| | Applicant Arguments/Remarks Made in an Amendment | | 7 | 9 | |
| Warnings: | | | | | |
| nformation: | | | | | |
| 2 | | QIM04_50143_POA.pdf | 180125 | yes | 2 |
| | | | dab702d95c459f334dcbe75b3/bcc0e63 be1ca16 | | |
| | Multipar | t Description/PDF files in | .zip description | | |
| | Document Description | | Start | End | |
| | Power of Attorney | | 1 | 1 | |
| | Assignee showing of ownership per 37 CFR 3.73(b). | | 2 | 2 | |
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.